

Docket No.: 1592-0178PUS1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Masanori SAKAI et al.

Application No.: 10/549,698

Confirmation No.: 9561

Filed: July 14, 2006

Art Unit: 1792

For: SUBSTRATE PROCESSING APPARATUS  
AND PRODUCING METHOD OF  
SEMICONDUCTOR DEVICE

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Examiner: K. T. Chen

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Madam:

**INTRODUCTORY COMMENTS**

In response to the final Office Action dated August 6, 2009, please amend the above-identified U.S. patent application as follows.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.